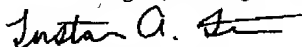


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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE****In re United States Patent Application of:****Applicant:** Van Buskirk, Peter C. et al.**Application No.:** 09/200,495**Date Filed:** November 25, 1998**Title:** OXIDATIVE TOP  
ELECTRODE DEPOSITION  
PROCESS, AND  
MICROELECTRONIC  
DEVICE STRUCTURE**Docket No.:** ATMI-337 RCE3**Examiner:** HU, Shouxiang**Confirmation No.:** 4898**Art Unit:** 2811**Customer No.:** 25559**FACSIMILE TRANSMISSION CERTIFICATE****ATTN: Examiner Hu**  
**Fax No. (703) 872-9306**

I hereby certify that this document is being filed in the United States Patent and Trademark Office, via facsimile transmission to Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on **October 7, 2004** to United States Patent and Trademark Office facsimile transmission number (703) 872-9306.

**19****Number of Pages (including cover)****Tristan A. Fuierer****October 7, 2004****Date****RESPONSE TO JULY 14, 2004 OFFICE ACTION  
IN U.S. PATENT APPLICATION NO. 09/200,495**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

This responds to the July 14, 2004 Office Action in the above-identified application.

2771-337 RCE3

Please amend the application as set out in the following **Section I** (Amendment of the Claims).

Remarks addressing the substance of the July 14, 2004 Office Action are set out in **Section II** (Remarks) hereof.